

Notice of References Cited

Application/Control No.

09/941,817

Applicant(s)/Patent Under
Reexamination
SEIBEL ET AL.

Examiner

David L. Hogans

Art Unit

2813

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	U	Van Zant, Peter; Microchip Fabrication 2000; McGraw-Hill, Fourth Edition; pages 331, 403-404, and 411-412
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*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)
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